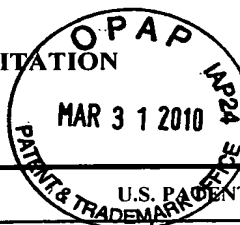


# INFORMATION DISCLOSURE CITATION

(Use several sheets if necessary)



Docket Number (Optional) <b>NE353-PCT(US)</b>	Application Number <b>10/594,307</b>
Applicant(s) <b>Hiroyuki YAMAZAKI</b>	
Filing Date <b>September 27, 2006</b>	Group Art Unit <b>2828</b>

## U.S. PATENT DOCUMENTS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		US 6,643,421 B1	11/04/2003	Chin et al. (Previously cited)			
		US 4,852,117	07/25/1989	Po (Previously cited)			
		US 6,668,006 B1	12/23/2003	Margalit et al. (Previously cited)			

## U.S. PATENT APPLICATION PUBLICATIONS

*EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
		US 2003/0219045 A1	11/27/2003	Orenstein et al. (Previously Submitted)			

## FOREIGN PATENT DOCUMENTS

	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
							YES	NO
		WO 03/071641 A2	08/28/2003	WIPO			✓	

## OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages, Etc.)

Chinese Office Action dated January 22, 2010 with English translation thereof.

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP Section 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.